I Year I Semester L P C

Code: 17CC103 4 0 3

SPECIAL MANUFACTURING PROCESS

UNIT-I

SURFACE TREATMENT: Scope, Cleaners, Methods of cleaning, Surface coating types, and ceramic and organic methods of coating, economics of coating. Electro forming, Chemical vapor deposition, thermal spraying, Ion implantation, diffusion coating, Diamond coating and cladding.

UNIT-II

PROCESSING OF CERAMICS: Applications, characteristics, classification .Processing of particulate ceramics, Powder preparations, consolidation, Drying, sintering, Hot compaction, Area of application, finishing of ceramics. Processing of Composites: Composite Layers, Particulate and fiber reinforced composites, Elastomers, Reinforced plastics, MMC, CMC, Polymer matrix composites.

UNIT-III

FABRICATION OF MICROELECTRONIC DEVICES:Crystal growth and wafer preparation, Film Deposition oxidation, lithography, bonding and packaging, reliability and yield, Printed Circuit boards, computer aided design in micro electronics, surface mount technology, Integrated circuit economics.

UNIT - IV

ADVANCED MACHINING PROCESSES: EDM, WireEDM, ECM, LBM, EBM, AJM, WJM– Principle, working, limitations and applications.

UNIT-V

RAPID PROTOTYPING: Working Principles, Methods, Stereo Lithography, Laser Sintering, Fused Deposition Method, Applications and Limitations, Rapid tooling, Techniques of rapid manufacturing

TEXT BOOKS:

- 1. Manufacturing Engineering and Technology I Kalpakijian / Adisson Wesley, 1995.
- 2. Process and Materials of Manufacturing / R. A. Lindburg / 1th edition, PHI 1990.

REFERENCES BOOKS:

- 1. Microelectronic packaging handbook / Rao. R. Thummala and Eugene, J. Rymaszewski /Van Nostrand Renihold,
- 2. MEMS & Micro Systems Design and manufacture / Tai Run Hsu / TMGH
- 3. Advanced Machining Processes / V.K.Jain / Allied Publications.
- 4. Introduction to Manufacturing Processes / John A Schey I Mc Graw Hill.